



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: To be assigned  
Examiner: Sharon Brooks

In Re PATENT APPLICATION Of:

Applicant(s): Hiroomi TSUTAE )

Serial No.: 10/657,207 )

Filed: September 9, 2003 )

For: Process of cleaning a semiconductor  
manufacturing system and method of  
manufacturing a semiconductor device )

Attorney Ref: FUJI 136 )

**STATUS REQUEST**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please let us know the status of the above-identified application and when an  
Action may be expected. If the response to this status request is made by telephone, please  
as for Tonya Harris (Docket Clerk) at extension 518.

Respectfully submitted,

August 11, 2005

Date

SMR:ss

Steven M. Rabin  
Steven M. Rabin  
Registration No. 29,102  
RABIN & BERDO, P.C.  
Customer No. 23995  
Tel: (202) 371-8976  
Fax: (202) 408-0924